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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: **T. SATOH et al.**
Application No.: **09/809,181**
Filing Date: **March 16, 2001**
Title: **SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF**
Art Unit: **2812**
Examiner: **D. Zarneke**

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.97 & §1.98

Assistant Commissioner of Patents
Washington, D.C. 20231

October 29, 2001

Sir:

In the matter of the above-identified application, applicant(s) is/are submitting herewith copies of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

The U.S. patent document listed on the attached form equivalent to Form PTO-1449 is in the English language.

To the extent that, the foreign documents listed on the attached form equivalent to Form PTO-1449, are not in the English language, the requirement of 37 CFR §1.98(a)(3) for a concise explanation of the relevance is satisfied by the abstracts attached to each of the foreign patents.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

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Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 01-2135 and please credit any excess fees to such deposit account.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Hung H. Bui", written over a horizontal line.

Hung H. Bui (Registration No. 40,415)
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HHB:srm
Attachments
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